

PATENT
8017-1195

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Takeshi NAKATA et al. Conf. 4547

Application No. 10/589,004 Group 2893

Filed August 10, 2006 Examiner Liu, Benjamin T.

SEMICONDUCTOR PHOTO-DETECTING ELEMENT

AMENDMENT

Assistant Commissioner for Patents January 28, 2009
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed July 29, 2008, for which the period for response has been extended three months, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 8 of this paper.

Remarks begin on page 9 of this paper.

An **Appendix** is attached following the signature page of this paper.